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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2818
Examiner: Quoc Dinh Hoang
Conf. No.: 6641

In Re PATENT APPLICATION of:

Applicant(s): Mitsumasa MURAISHI

Serial No.: 10/670,719

Filed: September 26, 2003

Allowed: May 17, 2005

For: METHOD OF FORMING A
SEMICONDUCTOR LASER CHIP
HAVING A MARKER

Atty. Dkt.: OKI 379

RESPONSE TO NOTICE REGARDING DRAWINGS

October 27, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Notice Regarding Drawings mailed on August 30, 2005, Applicant hereby submits two sheets of revised formal drawings, Figures 1(A) through 2(D). The drawings have been corrected to comply with 37 C.F.R. 1.84(m) and 1.84(p)(3). Please substitute these drawings for the drawings previously filed on September 26, 2003.

Respectfully submitted,

Robert Bend

October 27, 2005

Date _____

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